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Appl. No. 09/888,256
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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Howard et al.	Group Art Unit: 2861
Application No: 09/888,256	Examiner: Hai Chi Pham
Confirmation No: 8744	
Filed: June 22, 2001	Attorney Docket No: 004978 USA/ETEC/RWM
Title: ELECTRON BEAM PATTERNING WITH A HEATED ELECTRON SOURCE	June 18, 2003 San Francisco, California
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AMENDMENT UNDER 37 C.F.R. § 1.111

Commissioner for Patents
Washington, D.C. 20231

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Examiner Pham:

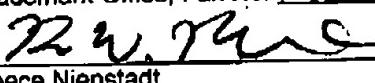
This communication is being timely filed in response to the Non-Final Office Action mailed on March 18, 2003, within three months and with no extension of time.

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